Q. Metrology, Inspection, and Yield Enhancement 분과 [FH1-Q] Nanoanalysis and Characterization

FH1-Q-1 09:00~09:30	[초청] Spectroscopic Ellipsometric Study on Temperature Dependence Dielectric Functions and Critical Point Energies for 2D Materials Tae Jung Kim¹, Hoang Tung Nguyen¹, Van Long Le¹, Xuan Au Nguyen¹, Do Hyoung Koo², Chul-Ho Lee², Farman Ullah³, Yong Soo Kim³, and Young Dong Kim¹ ¹Department of Physics, Kyung Hee University, ²KU-KIST Graduate School of Converging Science & Technology, Korea University, ³Department of Physics and Energy Harvest Storage Research Center (EHSRC), University of Ulsan
FH1-Q-2 09:30~10:00	[초청] Redefinition of kg Using Kibble Balance and its Application in Semiconductor Metrology Dongmin Kim KRISS
FH1-Q-3 10:00~10:30	[초청]Confocal Thermo-Reflectance Microscope and Applications Ki Soo Chang ¹ , Dong Uk Kim ¹ , Chan Bae Jeong ¹ , Ilkyu Han ¹ , Jung Dae Kim ¹ , Hyun Hwangbo ¹ , Seung-Woo Lee ² , and Byung-Seon Chun ² ¹ Division of Scientific Instrumentation, KBSI, ² Nanoscope Systems, Inc.